

Customer No. 22,852 Attorney Docket No. 07553.0008

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of:  | )                           |
|--|-----------------------------|
| Chishio KOSHIMIZU et al.   | ) Group Art Unit: 1765      |
| Application No.: 09/665,940  | ) Examiner: L. UMEZ ERONINI |
| Filed: September 21, 2000  For: PLASMA PROCESSING     APPARATUS AND PLASMA     PROCESSING METHOD  Commissioner for Patents | RECEIVED JUN 0 9 2003       |
| Washington, DC 20231   | TC 1700                     |

## PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one month extension of time to reply to the Office Action of February 13, 2003. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

By:

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: June 4, 2003

Sir:

Michael W. Kim Reg. No. 51,880

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06/05/2003 NABDELR1 00000062 09665940